

5/1/2007

Sheet 1 of 1

ATTACHMENT 1(a)

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  <b>LIST OF REFERENCES CITED BY APPLICANT</b>  <i>(Use several sheets if necessary)</i>	ATTORNEY DOCKET NO.	APPLICATION NO.
	1514.1030	10/734,162
	FIRST NAMED INVENTOR	
	Ji Yong PARK et al.	
	FILING DATE	GROUP ART UNIT
	December 15, 2003	2815

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
<del> </del>	AA						
<del> </del>	AB						
<del> </del>	AC						
<del> </del>	AD						
<del> </del>	AE						
<del> </del>	AF						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	TRANSLATION YES NO		ABSTRACT
<del> </del>	AG						
<del> </del>	AH						
<del> </del>	AI						
<del> </del>	AJ						
<del> </del>	AK						
<del> </del>	AL						

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

				TRANSLATION YES NO	
<del> </del>	AM	Office Action issued in Korean Patent Application No. 2002-80326 on November 22, 2004.		x	

EXAMINER	DATE CONSIDERED
<i>March C. Lee</i>	<i>6/29/07</i>
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

5/16/07

ATTACHMENT 1(a)

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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
<i>M</i>	AL	2002/0106586	8/2002	You			
<i>M</i>	AM	6,177,301 B1	1/2001	Jung			
<i>M</i>	AN	2002/0100937 A1	8/2002	Yamazaki et al			
<i>M</i>	AO	6,300,175 B1	10/2001	Moon			
	AP						
	AQ						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	TRANSLATION YES NO		ABSTRACT
<i>M</i>	AR	WO 97/45827	12/1997	WIPO			Abstract only
<i>M</i>	AS	GB 2 338 343	12/1999	Great Britain			Abstract only
	AT						
	AU						
	AKV						
	AW						

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

			TRANSLATION YES NO	
	AX			

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<i>Mark</i>	6/29/07
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<i>m</i>	AA	5,858,823	1/1999	Yamazaki et al.			
<i>m</i>	AB	2002/0182833 A1	12/2002	Yang			
<i>m</i>	AC	6,184,541 B1	2/2001	Oka et al.			

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	TRANSLATION YES NO		ABSTRACT
<i>m</i>	AD	EP 1 020 899 A1	7/2000	European			
<i>m</i>	AE	JP 11-168216	6/1999	Japan			x
<i>m</i>	AF	JP 11-354800	12/1999	Japan			x
<i>m</i>	AG	WO 02/09192	1/2002	WIPO			Abstract only
<i>m</i>	AH	EP 0 565 231 A2	10/1993	European			Abstract only

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

			TRANSLATION YES NO	
<i>m</i>	AI	Search Report issued in corresponding European Patent Application No. 03090437.9-1528 on February 21, 2007		
<i>m</i>	AJ	Ishihara R et al., "Location Control of Large Grain Following Excimer-Laser Melting of Si Thin-Films", March 1998, Tokyo, Japan, Vol. 37, No. 3B, pages 1071-1075.		
<i>m</i>	AK	Office Action issued in corresponding Japanese Patent Application No. 2003-297912 on March 9, 2007.		x

EXAMINER  <i>Matthew C. [Signature]</i>	DATE CONSIDERED  <i>6/29/07</i>
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